Docket No.740819-548

In re Patent Application of:

Mitsuru TANABE

Serial No. 09/838,214

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2817

Examiner: Benny T. Lee

Filed: 04/20/2001

MICROSTRIP LINE, METHOD FOR FABRICATING THE SAME, INDUCTOR

ELEMENT, AND RF SEMICONDUCTOR

DEVICE

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231, on October 32 2002.

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents Washington, D.C. 20231

Sir:

In response to the Office Action mailed September 24, 2002, applicant hereby elects Invention I, readable upon claims 1-4, 6, and 7 drawn to electrically conductive elements. Further applicant elects Species I: a microstrip line (claims 1-4).

These elections are made without traverse.

Respectfully submitted,

Thomas W. Cole

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LECHNOLOGY CENTER 5000

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